

"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 2814"

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SEP 15 2003

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF : :

HIROSHI WATANABE ET AL. : EXAMINER: PHAM, HOAI V.

SERIAL NO. : 09/973,019 : :

FILED: OCTOBER 10, 2001 : GROUP ART UNIT: 2814

FOR: SEMICONDUCTOR DEVICE AND:
METHOD OF MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS
ALEXANDRIA, VA 22313

SIR:

In response to the Official Action dated June 18, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 4 of this paper and include an attached replacement sheet and new drawing sheet.

Amendments to the Claims begin on page 5 of this paper.

Remarks/Arguments begin on page 18 of this paper.

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